NOV 1 6 2006

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Application Number	10/553,470
Filing Date	May 19, 2006
First Named Inventor	Raif LERNER
Art Unit	2812
Examiner Name	-Unassigned-/Andres Lopez Esquerra/
Attorney Docket Number	60201 000041

Sheet 1 of 3 Attorney Docket Number 60291.000041

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*Examiner Indials	Cite No.	DOCUMENT NUMBER Number - Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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					Raif LERNER					
STATEMENT BY APPLICANT					Art Unit Examiner Name		2812 **Transaigned* /Andres Lopez Esquerra/			
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		———	Retia da Invecazio, j	Examiner Name	************** /Andres Lope	ra/		
Sheet		3 of 3		Attorney Docket Number	60291.000041	60291.000041		
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